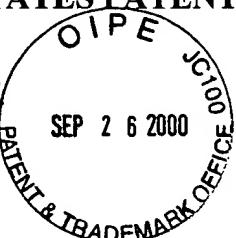


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re the application of: Wilk *et al*
 Serial No.: 09/176,422
 Filed: 10/21/98
 For: Low Temperature Method for Forming a Thin, Uniform Oxide

Docket: TI-24742
 Examiner: N. Berezny
 Art Unit: 2823

GAU 2823
 5/FH. 2
 9/29/00
 JEL
 SEP 28 2000
 TECHNOLOGY CENTER 2800

Petition For Extension of Time Under 37 C.F.R. § 1.136

September 20, 2000

Assistant Commissioner For Patents
 Washington, D. C. 20231

MAILING CERTIFICATE UNDER 37 C.F.R. § 1.8
 I hereby certify that this correspondence is being deposited with the
 United States Postal Service as first class mail in an envelope
 addressed to: Assistant Commissioner for Patents, Washington,
 DC 20231 on September 20, 2000.


 David Denker Reg. No. 40,987

Dear Sir:

Applicants respectfully petition the Commissioner for a two month extension of the shortened statutory period for response in the above-identified application.

Please charge this and any other required fee—including additional extension of time fees—to the deposit account of Texas Instruments Incorporated, Account No. 20-0668. Any further necessary extension of time is hereby requested. **Two additional copies of this sheet are enclosed.**

Respectfully submitted,


 David Denker
 Reg. No. 40,987

10/02/2000 TDWKINS 00000001 200668 09176422
 01 FC:116 380.00 CH
 02 FC:103 54.00 CH

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